

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q96773

Takeyoshi KANO, et al.

Appln. No.: 10/594,227

Group Art Unit: 3729

Confirmation No.: 3397

Examiner: Carl J. ARBES

Filed: September 25, 2006

For: METHOD FOR FORMING SURFACE GRAFT, METHOD FOR FORMING  
CONDUCTIVE FILM, METHOD FOR FORMING METHOD PATTERN, METHOD  
FOR FORMING MULTILAYER WIRING BOARD, SURFACE GRAFT MATERIAL,  
AND CONDUCTIVE MATERIAL

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 18, 2009, please consider the remarks as  
submitted herewith on the accompanying pages.

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